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Signature



JAN 30 2006

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s):	Bedell et al.	Examiner:	Heather A. Doty
Serial No.:	10/710,826	Group Art Unit:	2813
Confirmation No.:	4825	Date:	1/30/06
Filed:	August 5, 2004	Attorney Docket No:	FIS920040069
Title:	METHOD OF FORMING STRAINED SILICON MATERIALS WITH IMPROVED THERMAL CONDUCTIVITY		

**AMENDMENT AND RESPONSE**

Mail Stop Non-Fee Amendment  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to an Office Action mailed October 31, 2005 by the United States Patent and Trademark Office in connection with the above-identified Application. A response to this October 31, 2005 Office Action is due by January 31, 2006. Therefore, this response is being timely filed.

**Amendments to the claims** begin on page 2 of this paper.

**Remarks** begin on page 5 of this paper.

FIS920040069

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